## Accredited Standards Committee<sup>\*</sup>

# X3, Information Processing Systems

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 X3T10/95-350R0

 Date:
 November 8, 1995

 Project:
 X3T10-1048D

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 X3T10/94-057

 Reply to:
 R. Roberts

## To: Membership of X3T10

From: R.K. Roberts

#### Subject: Minutes of X3T10 MMC Working Group - November 8, 1995

## <u>Agenda</u>

- 1.0 Opening Remarks
- 2.0 Introductions
- 3.0 Document Distribution
- 4.0 Call for Patents
- 5.0 Approval of Agenda
- 6.0 Meeting Agenda
  - 6.1 HP Write process proposal (R Sims)
- 7.0 New Business
- 8.0 Review of Action Items
- 9.0 Future Meeting Schedule
- 10.0 Adjournment

#### <u>Minutes</u>

1.0 Opening Remarks

R. Roberts called the meeting to order at 1 PM. He thanked Jeff Stai and Western Digital for hosting the meetings.

2.0 Introductions

Introductions of attendees was made and sign-up sheet was passed around. Attendance list is attached.

3.0 Document Distribution

Documents distributed were for the HP Write Process

4.0 Call for Patents

The normal request for patent disclosures was made. No patents were identified.

5.0 Approval of Agenda

<sup>\*</sup>Operating under the procedures of The American National Standards Institute.

X3 Secretariat, Computer and Business Equipment Manufacturers Association (CBEMA) 1250 Eye Street NW, Suite 200, Washington, DC 20005-3922 Telephone: 202-737-8888 (Press 1 twice) FAX: 202-638-4922 or 202-628-2829 The agenda was modified to included section 6.2.

- 6.0 Meeting Agenda
  - 6.1 HP Write process proposal (R Sims)

Rob Sims of HP presented the write process from the last working group meetings. He review each line in detail and made the requested changes to the command fields. The process and associated commands were accepted by the working group and requested that the editor incorporate the appropriate pieces into Rev 4 of the MMC document. No electronic copy was given to the editor to include in the minutes.

6.2 Introduction of PD devices.

D. Worrell of WD ask if this working group was going to include a set of commands for PD devices. The group, with no dissenting vote, indicated that they felt that MMC-2 will contain the commands for PD devices.

- 7.0 New Business No new business
- 8.0 Review of Action Items

Action Item - R. Roberts to incorporate the Write Process into MMC document Action Item - Philips to provide date and time for next working group meeting in Sunnyvale.

9.0 Future Meeting Schedule

The next meeting of the working group will be held in Sunnyvale, CA. Philips Semiconductor has agreed to host. The timeframe is Dec. 5 - 7. The actual dates will be on the reflectors.

The January meetings in Dallas will be a day and half meeting. The schedule is 1-9 PM on Tues. 1/9/96 and 9 AM - 6 PM on Wed 1/10/96. These dates were approved by the plenary.

10.0 Adjournment

The meeting adjourned at 5:15 PM.

For changes or additions to the minutes contact:

Ron Roberts SIERRA-Pac Technology PO Box 2389 Shingle Springs, CA 95682 Ph 916-677-5714 Fax 916-677-1218 e-mail: rkroberts@aol.com MMC Attendance List for November 8, 1995 at Palm Springs, CA.

Name	<u>S</u>	Organization	E- Mail Address
Mr. Chris Brown	V	Apple Computer, Inc.	brown.c@applelink.apple.c
Mr. Ron Roberts	А	Apple Computer, Inc.	rkroberts@aol.com
Mr. Florey Lin	A#	Cirrus Logic Inc.	florey@cirrus.com
Mr. Robert Reisch	Ρ	Eastman Kodak Co.	reisch@sector.kodak.com
Mr. J. R. Sims	A#	Hewlett Packard Co.	robsims@depeche.lvld.hp.com
Mr. Duncan Penman	Р	IIX Consulting	penman@netcom.com
Mr. Neil Sugie	V	Mitsumi	n_sugie@alphap.com
Mr. Jack Chen	A#	Oak Technology, Inc.	jackc@oaktech.com
Mr. Bill McFerrin	0	Philips LMSI	Bmcferrin@aol.com
Mr. Sunil Nethisinghe	0	Philips Semiconductors	nethisin@scs.philips.com
Mr. Mike Yokoyama	Р	Sony Electronics, Inc.	masayuki@cppc.sel.sony.co
Mr. Devon Worrell	A#	Western Digital Corp	worrell@dt.wdc.com
Mr. Jonathan L. Hanmann	0	Western Digital Corp	hanmann_j@a1.wdc.com
Mr. Masa Morizumi	V	Yamaha Corp.	mori@lab1.yamaha.co.jp

14 People Present

Status Key: P - Prir	rincipal
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- A,A# Alternate
- O Observer
- L Liaison
- V Visitor